

IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicant:	Takanori ICHIKI	Conf:	5623
Serial No.:	11/590,969	Art Unit:	1759
Filed:	January 5, 2007	Examiner:	TAI, Xiuyu
For:	MICRO PLASMA JET GENERATOR		

REPLY UNDER 37 C.F.R.1.114

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Due May 3, 2011

Sir:

In response to the Office Action mailed February 03, 2011, and the Advisory Action dated April 20, 2011, the following remarks are respectfully submitted in connection with the above-identified application:

This Paper includes
Amendments to the Claims,
Remarks, and
Copy of "Review of Inductively Coupled Plasmas for Plasma Processing."

A Request for Continued Examination (RCE) is being filed concurrently.